## Possibility of BCLA+PTRF-EXAFS

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A bent crystal Laue analyser combined with polarization-dependent total reflection fluorescence X-ray absorption Fine Structure (PTRF-XAFS) is a promising technique for *in situ* surface analysis of highly dispersed systems even in the presence of solution.

#### 1 Introduction

Polarisation-dependent total reflection fluorescence extended X-ray absorption fine structure (PTRF-EXAFS) spectroscopy is a powerful technique to determine the three-dimensional structures of metal atoms (10<sup>13–15</sup> cm<sup>-2</sup>) dispersed on atomically flat surfaces[1]. When it is applied to the electrode surface which is covered with solutions, the elastic X-ray scattering of the liquid overlayer becomes large and seriously increases the background X-rays. We used BCLAn(Bent Crystal Laue Analyzer) to remove the elastic scattering from the solution and to allow the PTRF-XAFS measurements under the solutions.

#### 2 Experimental

A thin Pt layer was deposited on a 60-nm-thick polycrystalline Au thin film evaporated on a 10-mm  $\times$  20-mm Si(100) wafer by self-terminating electrodeposition[3]. Pt was electrochemically deposited on a Au polycrystal from 3 mmol K<sub>2</sub>PtCl<sub>4</sub>– NaCl at pH = 4 with an applied voltage of -0.7 V vs. Ag/AgCl. The deposition time was 20 s. Hereafter, the sample is called Pt/Au/Si. The EXAFS measurements were carried out under the total reflection conditions at beamline BL-15A1. The BCLA was set between the sample and the detector.

### 3 Results and Discussion

Figure 1 shows the  $\chi(k)$  of L<sub>3</sub>-edge EXAFS of Pt/Au/Si under the total reflection conditions (s-polarization) in a fluorescence mode with and without the BCLA, respectively. In the EXAFS spectrum without the BCLA, strong Au L<sub>a</sub> X-ray

fluorescence appeared above 11900 eV (the Au L<sub>3</sub> edge). Even under the total reflection conditions, X-rays could penetrate the bulk and excite the Au edge [2]. The BCLA reduced the PtL<sub> $\alpha$ </sub> fluorescence X-ray signal to 1/160 of that without the BCLA, i.e., 0.0024 and 0.38 at 11800 eV with and without the BCLA, respectively. However, S/B ratio was tremendously improved to 11000(with BCLA) from 140 (without BCLA). The S/N ratio of  $\chi$ (k) was 1.5 times better with than without the BCLA. This work suggests that, we can measure an EXAFS of the thick solution covered surface.



Figure 1 EXAFS oscillations  $(\chi(k))$  for Pt L $\alpha$  of Pt on Au (a) with and (b) without the BCLA.

References

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